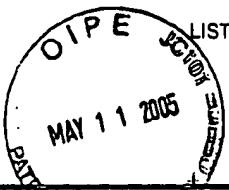


Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1398		SERIAL NO. 09/536,037	
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Li et al.			
					FILING DATE March 27, 2000		GROUP 2822	
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
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		Document Number <u>TW 471112A</u>	Date 01/01/2002	Country Taiwan – Abstract	Class	Subclass	Translation	
							Yes	No
JM	AJ	<u>TW 471112A</u>	01/01/2002	Taiwan – Abstract			X	
	AK							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM	Wolf, S., and Tauber, Richard, Silicon Processing for the VLSI Era; Vol. 1; Process Technology; "Silicon: Single Crystal Growth and Wafer Preparation"; pages 1 and 2						
	AN							
EXAMINER <u>J. M. Thomas</u>		DATE CONSIDERED <u>12-08-05</u>						
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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Weimin Li et al.		
					FILING DATE March 27, 2000		GROUP 2822
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							Yes
							No
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AM						
	AN						
	AO						
EXAMINER J. M. Thomas		DATE CONSIDERED 10-08-05					
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